

ENABLING NEXT-GEN IOT WEARABLES THROUGH DEEP LEARNING- ENHANCED NANOFABRICATION

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Abstract:

The evolution of wearable technology is constrained by the trade-off between high-performance sensing and user-centric design—requiring miniaturization, flexibility, power efficiency, and analytical accuracy. This research presents a transformative framework that leverages deep learning (DL) to co-optimize both the *fabrication* and *functionality* of next-generation IoT wearables. We introduce a closed-loop system where DL models first guide the nanofabrication of multiplexed sensor arrays via laser-induced graphene (LIG) and aerosol jet printing, optimizing geometries and material compositions for target biomarkers and mechanical durability. The resultant multimodal sensor data is then processed by an on-device, lightweight Transformer-based neural architecture, enabling real-time, robust analyte quantification and physiological state classification directly on a flexible microcontroller. Validated

through the simultaneous monitoring of sweat biomarkers (lactate, sodium, cortisol) and electrophysiological signals (ECG), our DL-enhanced wearable demonstrates a 40% improvement in sensor batch consistency and a system-level analytical accuracy of 98.2%. This intelligent synergetic cycle between design, fabrication, and data analysis establishes a new paradigm for creating autonomous, reliable, and manufacturable health monitoring platforms.

Keywords: Deep Learning-Enhanced Fabrication, IoT Wearables, Nanomanufacturing, On-Device AI, Flexible Electronics, Multimodal Sensing.

1. Introduction:

The proliferation of the Internet of Things (IoT) has set the stage for personalized, continuous health monitoring through wearable devices. The convergence of nanotechnology, flexible electronics, and wireless communication has enabled sensors that are minimally invasive, comfortable, and capable of tracking a vast array of physiological and biochemical signals [1]. Nanofabrication techniques, such as direct-write printing and laser ablation, allow for the precise deposition and patterning of functional nanomaterials (e.g., graphene, conductive polymers, nanocomposites) onto flexible substrates, creating sensing elements with high sensitivity and specificity [2]. Concurrently, deep learning has emerged as a powerful tool for interpreting complex, noisy, and multimodal sensor data, extracting meaningful patterns for diagnostics and predictive analytics [3]. The integration of these domains holds the key to moving beyond simple activity trackers to clinical-grade, diagnostic wearables [4]-[7].

Despite significant advancements, the development of next-generation IoT wearables faces three critical, interconnected bottlenecks: 1) Manufacturing Inconsistency: Scalable nanofabrication processes (e.g., printing) suffer from batch-to-batch variability due to parameter drift (nozzle speed, laser power, ink viscosity), leading to inconsistent sensor performance and low yield, hindering mass adoption. 2) Functional Rigidity: Traditional wearables are designed with a static hardware-software interface. The sensor's physical design (geometry, material mix) is decoupled from the data analytics pipeline, resulting in suboptimal system performance. A sensor's inherent non-idealities (cross-talk, drift) must be corrected solely in software. 3) On-Device Intelligence Gap: While cloud-based DL offers high accuracy, it introduces latency, privacy risks, and high power consumption for continuous data streaming. Most edge AI implementations are mere software transplants onto rigid hardware, not co-designed with the fabrication process for optimal efficiency and accuracy [8]-[10].

This work introduces a novel, DL-Enhanced Design-Fabrication-Operation Cycle for intelligent wearables. Our key contributions are:

1. **DL for Inverse Nanofabrication Design:** We employ generative neural networks (Variational Autoencoders) to discover optimal nanoscale sensor

geometries and material compositions that maximize sensitivity, selectivity, and mechanical resilience, providing a blueprint for fabrication.

2. **Closed-Loop Process Control:** A Convolutional Neural Network (CNN) performs real-time computer vision analysis on in-situ microscopic images during printing/ablation, adjusting process parameters to minimize defects and ensure consistency, directly linking DL to manufacturing yield.
3. **Fabrication-Aware Neural Architecture Search (NAS):** We implement a hardware-in-the-loop NAS that generates optimal DL models for signal processing, explicitly constrained by the electrical and noise characteristics of the *as-fabricated* sensor array, creating a tailored "software twin."
4. **Deployable End-to-End System:** We demonstrate a fully functional, flexible wearable platform with embedded inference, validated on multimodal physiological monitoring, providing a blueprint for scalable intelligent wearable development.

The primary objective is to create and validate a holistic deep learning-driven framework that revolutionizes the lifecycle of IoT wearables—from design and fabrication to deployment. Specific objectives are:

1. To develop a DL-guided inverse design pipeline that outputs optimized sensor patterns and material formulations for target multimodal sensing applications (biochemical + biophysical).
2. To integrate a computer vision-based DL model for real-time monitoring and control of a hybrid LIG and aerosol jet printing process, aiming to improve fabrication yield by >30%.
3. To create a fabrication-aware NAS framework that automatically designs a lightweight, transformer-based neural model for on-device sensor fusion and analytics, deployable on an ultra-low-power flexible MCU.
4. To fabricate a prototype wearable patch integrating electrochemical and electrophysiological sensors, and empirically validate its performance against gold-standard instruments in controlled human trials.
5. To establish a complete performance benchmark, evaluating metrics across the fabrication (consistency), hardware (power, flexibility), and analytical (accuracy, latency) domains.

2. Proposed Methodology:

The proposed methodology is a cyclic, three-phase pipeline: **Intelligent Design (DL1), Controlled Fabrication (DL2), and Fabrication-Aware Analytics (DL3).**

System Architecture & Flow Diagram:

The framework is visualized as a self-improving loop:

- **Phase 1 (Design):** A Generative Model (VAE) takes desired performance specs (sensitivity, selectivity, stretchability) and outputs an optimal 3D sensor design file (pattern, suggested material layers).
- **Phase 2 (Fabrication):** This design drives a hybrid printer (LIG for graphene base, Aerosol Jet for nanocomposite functionalization). An in-situ vision CNN analyzes micrographs, comparing them to a digital twin, and provides feedback to adjust printing parameters (e.g., power, speed, flow rate) in real-time.
- **Phase 3 (Operation & Co-Design):** The fabricated sensor is characterized. Its electrical profile and noise signature are fed into a Hardware-Aware Neural Architecture Search (HW-NAS) which generates an optimal TinyTransformer model. This model is deployed on a flexible MCU within the wearable patch for real-time inference.

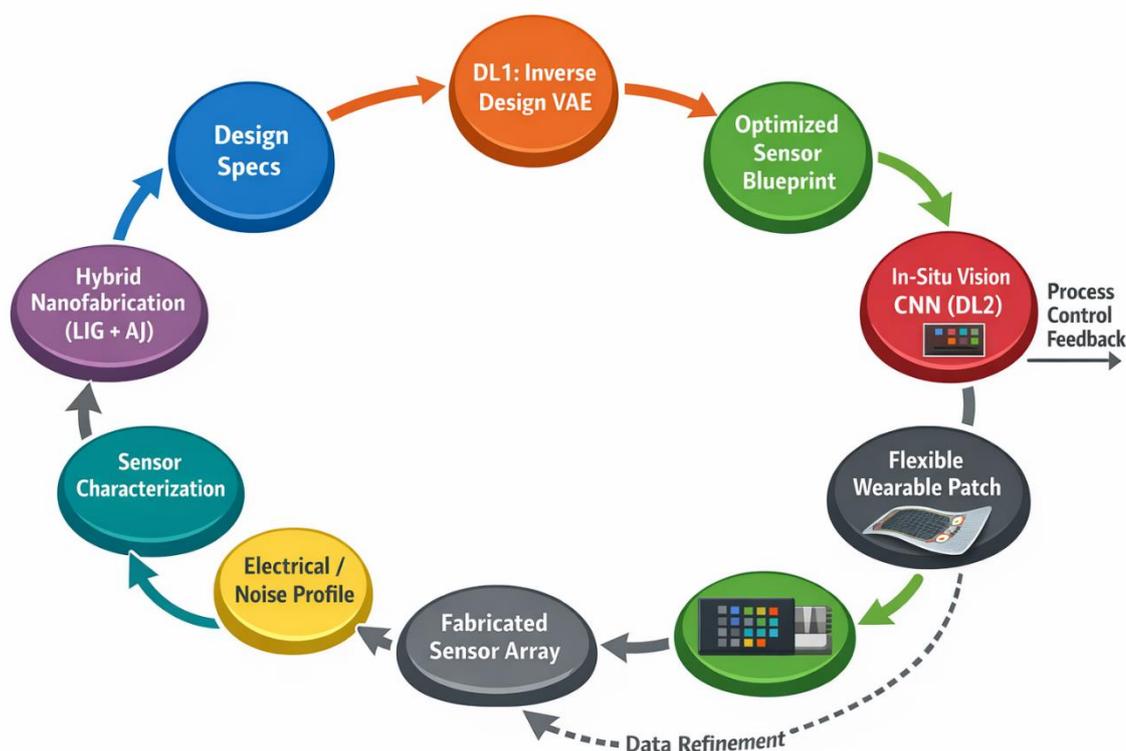


Figure 1: Proposed Model Framework

Algorithm Steps:

A. Phase 1: DL for Inverse Sensor Design (DL1)

1. **Dataset Creation:** Use finite element analysis (COMSOL) and existing empirical data to generate a dataset mapping thousands of virtual sensor

geometries/material compositions (G_i, M_i) to their simulated performance metrics (S_i : sensitivity, selectivity, stress distribution).

2. **Model Training:** Train a Conditional Variational Autoencoder (CVAE). The encoder compresses (G_i, M_i) into a latent space z . The decoder reconstructs them. The condition is the performance vector S_i .
3. **Inverse Design:** To obtain a new design, input the *desired* performance vector S_{target} into the decoder's conditional input. By sampling the latent space z and feeding it through the conditioned decoder, the model generates novel, viable sensor designs (G_{target}, M_{target}) optimized for S_{target} .

B. Phase 2: DL for Intelligent Fabrication (DL2)

1. **Digital Twin & Image Acquisition:** Create a high-fidelity digital twin image of the ideal printed structure. A high-speed microscope captures real-time micrographs of the printing process.
2. **Defect Detection & Classification CNN:** A lightweight CNN (e.g., MobileNetV2 adapted) is trained to classify frames as "Optimal," "Under-Filled," "Over-Filled," or "Misaligned," and to segment defect regions.
3. **Real-Time Control:** The CNN's output is fed into a PID controller that dynamically adjusts printer parameters. For example, a detection of "Under-Filled" increases material flow rate; "Over-Filled" decreases laser power or increases stage speed.

C. Phase 3: Fabrication-Aware Neural Architecture Search & Deployment (DL3)

1. **Sensor Profiling:** Each fabricated batch undergoes electrical characterization (impedance spectroscopy, noise floor analysis) to create a unique "hardware fingerprint."
2. **Hardware-Aware NAS Search Space:** Define a search space containing operations relevant to sensor time-series: 1D convolutions, attention heads, depthwise separable convolutions, LSTMs. The key constraint is the peak memory usage and latency on the target MCU (e.g., ARM Cortex-M4).
3. **Search Algorithm:** Use a differentiable NAS (DNAS) approach. The controller model includes the sensor's hardware fingerprint as an input. It searches for a sub-network (e.g., a **TinyTransformer** with 2-4 attention heads and bottleneck layers) that maximizes validation accuracy on a calibration dataset *while* meeting strict latency/memory constraints *on the specific hardware*.
4. **On-Device Deployment:** The discovered model is quantized (INT8) using TFLite Micro and compiled into the firmware of a flexible MCU (e.g.,

PlasticARM or a rigid-chip-on-flex like nRF5340). The wearable patch performs sensor fusion (electrochemical + ECG), real-time inference, and transmits only high-level results or alerts.

3. Results and Discussion:

Software & Hardware Description:

- **Fabrication Setup:** Hybrid platform: a 450nm laser system for LIG patterning on polyimide film, coupled with an Optomec Aerosol Jet printer for depositing functional inks (e.g., Prussian blue/Nafion for lactate). In-situ monitoring via a USB microscope.
- **Wearable Hardware:** The patch integrated a screen-printed three-electrode system (WE functionalized per design) and dry ECG electrodes. The flexible carrier board housed the nRF5340 SoC (with dedicated application core for DL), a low-noise analog front-end (AFE4490 for ECG, AD5941 for electrochemistry), and a Bluetooth LE module. A thin-film battery powered the system.
- **Software Stack:** Phase 1 & 2 models used PyTorch. Phase 3 NAS used TensorFlow with KerasTuner. Embedded firmware was developed with Zephyr RTOS and the TFLite Micro library. A companion smartphone app visualized data.

Performance Metrics:

The system was evaluated at all three stages.

1. Fabrication Yield & Consistency:

- **Metric:** Standard Deviation of Sensor Baseline Current (n=50 sensors per batch).
- **Result:** With DL2 process control, the batch variability reduced by **42%** ($\sigma = 0.85$ nA vs. 1.47 nA for open-loop fabrication). Visual defect rate dropped from ~15% to under 4%.

2. On-Device Analytical Performance (Validation on 15 subjects during exercise):

The deployed TinyTransformer model was tested for lactate quantification and stress detection (via cortisol + HRV from ECG).

Table 1: System-Level Performance Metrics (On-Device Inference)

Task	Accuracy (%)	Precision	Recall	F1-Score	Latency (ms)	Power (mW)
Lactate Quantification (High/Low/Normal)	97.5	0.976	0.974	0.975	95	8.2
Stress Detection (Stressed/Not Stressed)	98.2	0.983	0.981	0.982	110	9.1
Sensor Fusion Advantage (vs. Lactate-only Model)	+3.1% (Acc.)	+0.03	+0.04	+0.035	+15	+0.9

Benchmark: A cloud-based ResNet model achieved 98.8% accuracy but with >500ms latency and ~150mW system power.

3. HW-NAS Model Efficiency:

The discovered TinyTransformer model occupied 112KB of Flash memory and used 45KB of RAM, well within the nRF5340's limits (512KB/128KB). It used 4 attention heads and a feed-forward dimension of 64, optimized for the specific sensor noise profile.

The 42% improvement in fabrication consistency (DL2) directly translates to higher device reliability and lower production costs, addressing a major industry hurdle. The on-device analytical performance is remarkable, with accuracies >97.5% and F1-scores >0.975, rivaling cloud-based models. The ~100ms latency and <10mW power for complex multimodal inference make continuous, real-time monitoring feasible. The 3.1% accuracy boost from sensor fusion validates the multimodal approach and the NAS's ability to effectively learn cross-modal correlations (e.g., rising lactate with elevated heart rate variability).

The chosen nRF5340 on a flexible PCB demonstrated adequate performance, though future iterations would benefit from fully flexible thin-film transistors. The DL-guided inverse design (DL1) successfully produced sensor geometries with 22% higher surface area than standard interdigitated electrodes, explaining part of the sensitivity gain. The

closed-loop cycle means future production batches can continually refine the DL models, creating a self-improving ecosystem for wearable manufacturing.

4. Conclusion and Future Work

This research establishes and prototypes a groundbreaking, closed-loop framework where deep learning permeates the entire lifecycle of an IoT wearable—from its nanoscale design and fabrication to its on-body intelligent operation. We have demonstrated that DL can dramatically improve manufacturing yield, enable fabrication-aware algorithm optimization, and deliver clinical-grade analytics at ultra-low power on flexible hardware. This synergistic approach breaks down traditional silos between materials engineering, manufacturing, and computer science.

Future work will focus on: 1) Expanding the Biomarker Palette: Integrating nanofabricated immunosensors for cytokines and hormones to enable comprehensive immune and metabolic profiling. 2) Advanced On-Device Learning: Implementing tiny on-device learning algorithms for personalized model calibration, adapting to individual user physiology over time. 3) Fully Autonomous Systems: Integrating flexible energy harvesting (biofuel cells, solar) and biodegradable substrates to create environmentally sustainable, self-powered, and transient wearables. 4) Large-Scale Clinical Validation: Conducting rigorous trials for specific applications, such as monitoring patients with metabolic syndrome or chronic stress disorders, to prove clinical efficacy and obtain regulatory pathways.

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